

Electronic Acknowledgement Receipt

EFS ID:	7682305
Application Number:	10586400
International Application Number:	
Confirmation Number:	3841
Title of Invention:	Vacuum Deposition Method and Sealed-Type Evaporation Source Apparatus for Vacuum Deposition
First Named Inventor/Applicant Name:	Hiroki Nakamura
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Filer:	Daniel G. Radler
Filer Authorized By:	
Attorney Docket Number:	520514.00039
Receipt Date:	25-MAY-2010
Filing Date:	20-APR-2007
Time Stamp:	14:14:11
Application Type:	U.S. National Stage under 35 USC 371

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	Response to Election / Restriction Filed	00039ele.pdf	29823 d792af748d2af8dbf33b1f0d8e447d2bf5a5f9e5	no	1

Warnings:

Information:

Total Files Size (in bytes):	29823
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.